



PTO/SB/08B (10-01)

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet

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Applicati n Number	09/808,790						
Filing Date	March 15, 2001						
First Named Inventor	Krishna Vepa et al.						
Art Unit	1765						
Examiner Name	Lan Vinh						
Attorney Docket Number	20468-000110						

U.S. PATENT DOCUMENTS								
		Document Number						
Examiner	Cite No.1	Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
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Examiner Signature		Date Considered	5/1/203

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Application Number

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Filing Date March 15, 2001

First Named Inventor Krishna Vepa et a

Art Unit 1765

Examiner Name Lan Vinh

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Sheet 2 4 Attorney Docket Number 20468-000110

	U.S. PATENT DOCUMENTS								
Examiner	Cite No.1	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or,) Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear				
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Art Unit	1765
Examiner Name	Lan Vinh
Attorney Docket Number	20468-000110

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1	CD	US 6,210,259 B1	04-03-2001	Daniel Malkin et al.					
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Examiner Cite Initials* No.1		Country Code ³ Number ⁴ Kind Code ⁵ (<i>ii known</i>)		Publication Date MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	Т ⁶		
	CAA	EP	0776030	A2	05-28-1997	Hisashi Masumura et al.			
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	CDD	JP C	10-146751	Α	06-02-1998	Not translated			
Examine Signature		\sqrt{M}	M		Date Considered	5/1/200	03		

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				FOREIGN PA	TENT DOCUM	ENTS			
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Examiner Initials *	Cite No.1	Include nar item (bo	ook, magazine, j	ournal, serial, s	ymposium, catalo	the article (when appropi g, etc.), date, page(s), v y where published.	riate), title of the olume-issue	T²	
LV	CLL	Systems Dynamics, Inc. web page, www.sysdyn.com/expages/LMIS.htm, May 2, 2001, 2 pages.							
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